

Electronic Acknowledgement Receipt

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Title of Invention:	Method and system for immersion lithography
First Named Inventor:	Chia-Hui Lin
Customer Number:	54657
Filer:	Steven E. Koffs/Wanda Staples
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Response to Election / Restriction Filed	TSMC20030813ResponseRestrictionRequirement.pdf	102420	no	2

Warnings:	
Information:	
Total Files Size (in bytes):	102420
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